THE ORIGIN OF SPONTANEOUS MUTATION IN SACCHAROMYCES CEREVISIAE

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ABSTRACT

Characterization of two antimutator loci in yeast shows that both are members of the same mutagenic repair system known to be responsible for almost all induced mutation (LAWRENCE and CHRISTENSEN 1976, 1979a,b; PRAKASH 1976). One of the these newly isolated antimutator mutations is an allele of rev3 (LEMONTT 1971b). Two other alleles of rev3 were tested and were also found to be antimutators. Double mutants carrying rev3 and mutator mutations of rad3, rad51 or rad18 are like rev3 single mutants with respect to spontaneous mutation rate, supporting the hypothesis (HASTINGS, QUAH and VON BORSTEL 1976) that many mutators in yeast act by channelling spontaneous lesions from accurate to mutagenic repair. However, the enhanced mutation rate seen in a radiation-resistant mutator mutant mut1 is not dependent on REV3, but is dependent on another gene designated ANT1. An additive effect on the reduction in spontaneous mutation, seen in the ant1 rev3 double-mutant strain, leads to the conclusion that at least 90% of spontaneous mutations seen in the wild type are caused by mutagenic repair of spontaneous lesions.

WHEN strains of yeast having enhanced mutation rates were isolated, it was found that a minimum of 10 genetic loci were responsible for the effect (HASTING, QUAH and VON BORSTEL 1976; ORD 1980). Most of these mutant strains are sensitive to mutagenic agents such as ultraviolet radiation (UV), gamma radiation and methyl methanesulfonate (MMS). This pleiotropic effect of mutator phenotype and sensitivity to mutagens is also observed among many of the repair-defective *rad* mutants. Of the 17 *rad* mutants examined, 10 are mutators (BRYCHCY 1974; BRYCHCY and VON BORSTEL 1977; HASTINGS, QUAH and VON BORSTEL 1976; VON BORSTEL, CAIN and STEINBERG 1971; S.-K. QUAH, unpublished results). Although none of the gene products of these mutator loci is known, it is unlikely that misreplication resulting from altered polymerases can account for such a large number of mutator loci in yeast.

It is evident from the study of induced mutagenesis in yeast that radiationsensitive mutants show induced mutation frequencies that differ from those found in wild-type strains because the mutations cause changes in the proportions of lesions that are channelled into various repair processes. Some of these repair processes are mutagenic, others are not (LAWRENCE and CHRISTENSEN 1976; LEMONTT 1971a). That these same radiation-sensitive mutants affect the

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rate of occurrence of spontaneous mutations strongly suggests that spontaneous lesions are repaired by systems having many steps in common with the systems repairing induced lesions. In other words, enhanced spontaneous mutation rates seen in mutator strains can be explained by the channelling of spontaneous lesions into mutagenic (error-prone) repair (HASTINGS, QUAH and VON BORSTEL 1976). This hypothesis leads to the prediction that antimutator strains that have lost mutagenic repair capacity could be isolated and that they will be deficient in repair. Strains defective in UV-induced mutagenesis have been isolated and analyzed (LAWRENCE and CHRISTENSEN 1976; LAWRENCE *et al.* 1974; LEMONTT 1971b; PRAKASH, HINKLE and PRAKASH 1979). Results from these studies suggest that error-prone repair occurs in yeast. We have attempted to show from the properties of antimutator mutants described in this report that at least one of the error-prone repair processes involved in repair of radiation-induced lesions is also available to spontaneous lesions and is the cause of the enhanced spontaneous mutation rate of some mutator strains.

The isolation of antimutator mutants that are involved in repair and affect the rate of spontaneous mutation allowed us to show that most spontaneous mutations in wild-type yeast also arise from mutagenic repair of spontaneous lesions.

MATERIALS AND METHODS

Yeast strains: Strains used in this study are presented in the text and in Table 1.

Media: The following media were used: YEPD medium (2% Difco peptone, 1% Difco yeast extract, 2% dextrose), YEPG medium (2% Difco peptone, 1% Difco yeast extract, 3% glycerol), FS or sporulation medium (2% potassium acetate, 0.1% glucose, 0.25% yeast extract, supplemented with the amino acids used in MC medium), synthetic complete or MC medium (0.67% Difco yeast nitrogen base without amino acids, 2% glucose, supplemented with amino acids as indicated in von BORSTEL, CAIN and STEINBERG 1971). Growth-limiting medium is MC medium with lysine or histidine in a limiting concentration as indicated in the section on the box test for measuring spontaneous mutation rates. For the limiting lysine experiments, 5 μ g/ml instead of 20 μ g/ml was used. Solid MC medium was supplemented with 2% agar. Solid YEPD, YEPG and SF media were supplemented with 1.5% agar.

The mutational systems: The mutational systems required that all the strains used carry a minimum of two nonsense mutations, lys1-1 and ade2-1, and a missense mutation, his1-7. Two other nonsense mutations, arg4-17 and trp5-48, were often included but were not essential, except in a few cases where the arg4-17 reversion rates were measured. Both lys1-1 and arg4-17 respond to nonsense suppressors that insert tyrosine at ochre codons. These forward mutations to suppressors (SS) can be distinguished from reversions at the nonsense site (locus) by virtue of their loss of red pigmentation due to suppression of the ade2-1 mutation. These two mutational systems within a lys1-1 reversions system were adopted by SCHULLER and VON BORSTEL (1974) in a 1,000-compartment fluctuation test (or box test) to measure spontaneous mutation rates. The third mutational system used involved the reversion of the missense mutation his1-7 from histidine dependence to independence.

UV sensitivity test: Stationary phase cells grown on YEPD plates were harvested and suspended in 5 ml of $M/15 \text{ KH}_2\text{PO}_4$, pH 4.5. Appropriate dilutions mere made and plated on YEPD. The plates were irradiated using a General Electric G30T8 germicidal lamp in a darkened room. A Laterjet UV meter was used for dosimetry.

Gamma radiation sensitivity test: Cells were prepared in the same way as described for UV radiation. A 60Co Gamma-Cell 220, from Atomic Energy of Canada Ltd., was used.

TABLE 1

Diploid number	Parental haploid strains	Genotype
YO191	Y0176-6D	a rev3-1 HIS+ HOM+
	YO600-14C	α
YO192	Y0177-5C	a rev3-1 LYS+ ADE+
	YO600-14C	α
YO326	X1687-16C-10	a rev3–3 his5–2 HIS1+ HOM3+ leu2–10 met1–1
	YO300-1B	α
YO102	YO95–1B	a rev3-15(ant2) ARG+ trp?
	YO300-1C	α
YO 414	E004-6D	a <i>rad3–12</i>
	YO102-4B	α rev3-15 TRP+
YO415	E004–6D	a rad3–12
	YO192-3B	α rev3-1 TRP+
YO418	E004–6D	a rad3–12
	YO300-1C	α
YO425	YO102–1C	a rev3-15 trp?
	YO318–1A	α
YO436	YO102-1C	a rev3-15 trp?
	XV407-19B	α rad51(mut5-1)
YO294	YO300-2C	a
	rs4	α rad18–3 no auxotrophic marker
YO424	YO294-4A	a rad18-3 TRP+
	YO102-4B	α rev3–15 TRP+
YO417	YO294-4A	a rad18-3
	YO192–3B	a rev3-1 TRP+
YO189	Y0800-1C	a mut1–1
	YO102-1B	α rev3-15 ARG+ trp?
YO43	XV803-4A	a ARG+TRP+HOM+leu1-12
	289	α mut1-1 ant1
YO133	YO43-9A	a $mut1-1$ ant1 ARG+ TRP+ HOM+
	YO300–1C	α
Y075	YO43-8B	a ant1 ARG+ TRP+ HOM + $leu1$ -12
	YO42–2A	α ARG+ TRP+ HOM+

Strain numbers and genotypes

Unless noted otherwise, all strains carry lys1-1, ade2-1, arg4-17, trp5-48, his1-7 and hom3-10.

Methyl methanesulfonate sensitivity test: Stationary-phase cells at a density of 5×10^6 in M/15 KH₂PO₄ buffer were spotted on YEPD medium supplemented with 0.035% MMS prepared as described by PRAKASH and PRAKASH (1977). The MMS was obtained from Terochem Laboratories Ltd., Edmonton.

Measuring spontaneous mutation rates (the lassie test): For a detailed description of this method, see von BORSTEL (1978). This is a simple reversion test on solid MC medium with either lysine (10 or 20 μ g/ml) or histidine (1 or 2 μ g/ml) as a growth-limiting factor. Revertant colonies appeared on a thin lawn of auxotrophic cells and were counted after 10 days at 27°.

Measuring spontaneous mutation rates (the 10-tube fluctuation test): Five ml of liquid YEPD for each strain was placed in each of 10 test tubes. A 3-day-old whole colony from a YEPD plate was inoculated into each tube. These cultures were grown for 3 days on a shaker. The cells were then washed and counted. One ml from each culture was plated on 2 plates of MC—lysine and 2 plates of MC — histidine. Revertants were counted after 5 days. This procedure was later simplified. Ten 5-day-old whole colonies grown on YEPD at a density of not more than 30 colonies per plate were separately suspended into 10 test tubes, each containing 2 ml of phosphate buffer. Cells were counted, and 1 ml from each tube was plated on one kind of omission medium. Ten colonies were plated for each reversion system. The number of revertants (per 10^8 cells) per culture were ranked and the median was used to compare the strains. This test is used qualitatively, mainly to show that reduced spontaneous mutation rates exhibited by the presumptive antimutator strains can be confirmed in a nonselective medium, in this case YEPD.

Measuring spontaneous mutation rates (the box test): This method of measuring spontaneous mutation rates has been described by SCHULLER and VON BORSTEL. (1974), VON BORSTEL (1978) and VON BORSTEL, CAIN and STEINBERG (1971). It is essentially a 1,000-compartment lassie test, done in MC liquid medium. Each compartment contains a 1 ml culture. Depending upon the experiment, the concentrations of lysine used were 0.5, 1, 1.5 or 2 μ g/ml, and histidine was at a concentration of either 0.2 or 0.3 μ g/ml. Mutation rates were estimated from the proportion of compartments without revertants.

The isolation of ant1: Stationary phase cells from strain YO800-6C ($\alpha mut1-1 lys1-1 ade2-1$ his1-7 hom3-10) were mutagenized by ethyl methanesulfonate (Eastman Kodak) following a modification of LINDEGREN's method (LINDEGREN et al. 1965) that was described by VON BORSTEL et al (1973). The mutant-screening protocol is essentially the same. Mutagenized cells were plated on YEPG (100 to 200 colonies per plate) and were incubated for 4 days. Each plate was then replica-plated onto a limiting lysine (10 μ g/ml) and a YEPD second-master plate. Colonies that did not papillate as much as the mut1-1 control strain on limiting lysine medium after 1 week were then subjected to a lassie test. About 10⁶ cells from each clone were plated on a limiting lysine (10 μ g/ml) plate. Revertants were counted after 10 days. Clones that showed counts lower than the mut1-1 control were subjected to 2 other tests, *i.e.*: (1) the 10-tube fluctuation test with YEPD, and (2) the box test. Clone 289 isolated in this manner was found to show sensitivity to UV radiation. When outcrossed to the wild-type strain XV803-4A (a lys1-1 ade2-1 his1-7 hom3-10), tetratype tetrads were recovered suggesting that a second mutation, designated ant1, had been induced in clone 289.

The isolation of ant2 (= rev3-15): The ant2 mutation was isolated in a haploid strain, XV846-10A (a lys1-1 ade2-1 trp1-1 leu2-1 his1-7 hom3-10), by VON BORSTEL and LYNCH (1978) in an experiment designed to determine the relative frequency of mutator and antimutator mutations induced by gamma radiation. Stationary-phase cells suspended in M/15 KH₂PO₄ phosphate buffer, pH4.5, were exposed to 10 Krad of ⁶⁰Co. Mutagenized cells were diluted and plated on YEPG. All plates were incubated at 30° for 3 days. Surviving colonies were subjected to the lassie test, using 2 μ g/ml of histidine. Clone B5496, showing a sensitivity to UV and a reduced spontaneous reversion rate for his1-7, was confirmed as an antimutator by a 10-tube fluctuation test with YEPD and a box test. The B5496 mutation designated ant2 was outcrossed to the wild-type strain XV185-6A (α lys1-1 ade2-1 arg4-17 trp5-48 his1-7 hom3-10). From this cross, the meiotic segregant YO95-1B, sensitive to UV, was used to expand the stock cultures carrying this antimutator mutation (see Table 1).

Construction of double mutants: The rad3-12 and rad6-1 mutations were isolated by Cox and PARRY (1968). The rev3-1 and rev3-3 mutations were isolated by LEMONTT (1971b). The rad18-3 (formerly rs4 mutation was isolated by SNOW (1967). The rad51 (formerly mut5-1) mutation (MORRISON and HASTINGS 1979) and the mut1-1 mutation (von BORSTEL et al. 1973) were isolated in our laboratory. Haploid strains used in these experiments were constructed by sporulating diploid strains whose genotypes relevant to this study are given in Table 1. Standard tetrad analysis procedures of yeast genetics were used throughout. Phenotypes of the spore cultures were determined by UV and gamma-ray sensitivity tests and by the lassie test. Single and double mutants were confirmed by backcrosses to tester strains. Wild-type strains referred to as RAD^+ , REV^+ , or ANT^+ in Table 1 are related to, but not necessarily isogenic with, XV185-14C and XV185-6A. We used more than one control strain from a cross or related crosses to overcome the lack of isogeny.

RESULTS

The antimutator mutation ant2 was induced by gamma radiation and was found to cause reduced his1-7 reversion. Further characterization showed that strains carrying this mutation are UV and MMS sensitive, but do not appear to be gamma-ray sensitive. Complementation, using UV survival, was found in diploids heterozygous for ant2 and each of the following mutants: ant1, rev1, rad6, rad9 and rad18, but, as shown in Figure 1, not rev3. Furthermore, 15 tetrads dissected from an ant2/rev3 diploid gave no UV-resistant recombinant. UV-induced reversion of his1-7, lys1-1 and arg4-17 was found to be lower in ant2 than in the wild-type strains (data not shown). We concluded that ant2is an allele of rev3 and therefore shall be referred to as rev3-15. LEMONTT (1971b) isolated 14 rev3 alleles by screening for resistance to UV-induced reversion.

The antimutator activity of strains carrying the new rev3-15 allele was compared to those of rev3-1 and rev3-3 isolated by LEMONTT (1971b). It can be seen in Table 2 that all three rev3 alleles significantly reduce lys1-1, arg4-17and his1-7 reversion rates. Suppressor mutation rates appeared to be slightly reduced; a clearer reduction is observed in subsequent experiments.



FIGURE 1.—UV survival curves of eight diploid strains showing that *ant2* does not complement *rev 3–1*.

Antimutator activity of three rev3 alleles

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	$(\times 10^8)$	Locus	0.02	l	1	I	0.04	1	0.02	0.05	0.03	ļ	0.06	0.02	0.03	ł	l	ł	l	0.15	0.23	0.12	0.09]	0.17	I	0.11
	Mı rate	SS	1.00		I	I	1.19	ļ	2.17	1.47	1.66		1.54	2.14	2.00	1	I	1	1	1.77	0.54	2.54	2.65		2.35		2.30
7	mutant tments	Locus	0	1	1	I	ষ		61	ŝ	ŝ	1	9	61	3	Ι	i	I	1	16	11	12	6	1	17	1	7
arg4–1	No. of 1 compar	SS	89		l	I	120	I	160	133	141]	139	164	177			1]	177	26	227	238	[214		137
	J. IN	comps.	986	I	1	I	9 95	I	895	666	9 95		1003	966	666	1	I	1		266	006	986	968	1	266	1	969
	Cells/	$(\times 10^{-6})$	4.72	Ι	I	I	5.41		4.55	4.85	4.59	I	4.86	4.21	4.88	1	1	1	I	5.52	2.71	5.15	5.13		5.14	1	4.77
		rate ($\times 10^{8}$)	1.29	3.47	0.75	0.68	2.56	3.43	3.54	1.86	2.25	1.17	1.20	2.12	1.66	7.49	4.63	10.51	9.56	9.61	9.37	8.64	8.38	9.80	5.32	1	5.05
	No. of	comps. 1	46	167	24	20	117	164	131	98	8 6	27	28	100	79	249	160	336	371	393	373	410	343	193	211	I	176
1-7	y T	comps.	987	1000	666	1000	9 68	1000	1000	966	966	959	981	1000	921	266	266	666	994	968	1000	266	966	966	666	Ī	1000
his	Cells/	$(\times 10^{-6})$	1.84	2.63	1.57	2.74	2.44	2.60	1.98	2.79	2.22	1.22	1.21	2.47	2.48	1.92	1.87	1.95	2.44	2.59	2.49	3.04	2.50	1.10	2.23		1.92
	tion (10 ⁸)	Locus	0.05	0.04	0.05	NR*	0.06	0.08	0.11	0.05	0.08	0.05	0.03	0.08	0.04	0.43	0.17	0.36	0.29	0.38	0.46	0.25	0.63	0.36	0.45	0.21	0.20
	Muta rate (>	SS	0.75	0.58	0.63	0.86	1.43	1.25	1.12	0.38	0.72	2.72	2.20	0.91	1.11	1.00	1.79	2.62	2.40	1.50	1.50	1.69	1.90	1.38	1.90	1.31	1.82
	iutant ments	ocurs	ŝ	°	4	0	4	7	5	01	Ť	Ŷ	01	8	3	28	12	29	24	34	37	22	36	32	34	10	15
	No. of m compart	SS]	48	46	52	47	93	109	51	16	34	193	148	83	92	2	120	195	180	128	116	138	105	117	135	62	133
lys1–1	No. of	comps.	898	1000	966	666	1000	666	1000	1000	1000	666	266	1000	1000	1000	266	1000	966	666	666	1000	978	1000	1000	1000	266
	Cells/	$(\times 10^{-6})$	3.66	4.07	4.23	2.81	3.42	4.63	2.34	2.15	2.41	3.95	3.66	4.75	4.23	3.32	3.58	4.14	4.15	4.58	4.12	4.39	2.99	4.52	3.82	2.44	3.84
		Strain	Y0191-1C	Y0191–2D	Y0191-2C	Y0191–3C	Y0192–3B	Y0192-4D	Y0326-6C	Y0326–9B	Y032610A	Y0102-1B	Y0102-1C	Y0102-3C	Y0102-4B	Y0191-1B	YO191-4B	Y0192-1B	Y0192-4C	Y0326-2B	Y0326–3B	Y0326-9A	Y0326-10B	Y0102–1A	Y0102-1D	Y0102–3A	Y0102-3B
		Mutation	rev3–1						rev3-3			rev3–15				Wild type											

TABLE 2

In order to test our hypothesis that radiation-sensitive mutator mutants derived their mutator phenotype from channeling of spontaneous lesions into mutagenic repair, we constructed strains doubly mutant at two genetic loci: a radiation-sensitive mutator mutation resulting in a block in error-free repair and a *rev3* mutation as a second block in mutagenic repair. The evidence for or against our hypothesis lies in the phenotype of such double mutants with respect to spontaneous mutation. The three radiation-sensitive mutator mutants chosen for this study represent three major epistasis groups as defined by UV- and gamma-radiation survival interaction in double mutants (BRENDEL and HAYNES 1973; Cox and GAME 1974; GAME and Cox 1972, 1973; GAME and MORTIMER 1974; KHAN, BRENDEL and HAYNES 1970; LAWRENCE and CHRISTENSEN 1976).

(1) Excision defective mutants in yeast (GAME and Cox 1972; PRAKASH 1977a,b; PRAKASH and PRAKASH 1979; RESNICK and SETLOW 1972; REYNOLDS 1978; UNRAU, WHEATCROFT and Cox 1971; WATERS and MOUSTACCHI 1974) are mainly UV sensitive and show enhanced UV-induced mutation frequencies (AVERBECK *et al.* 1970; ECKHARDT and HAYNES 1977; LAWRENCE and CHRISTENSEN 1976; LAWRENCE *et al.* 1974; MOUSTACCHI 1969; RESNICK 1969a; ZAKHAROV, KOZINA and FEDOROVA 1970). This is consistent with the idea that excision repair is largely error-free (LAWRENCE and CHRISTENSEN 1976). Studies of double mutants with regard to UV-induced mutagenesis showed that mutants defective in mutagenic repair are epistatic to mutants defective in excision repair (LAWRENCE and CHRISTENSEN 1976; LEMONTT 1971b). Only the *rad3* mutant shows the mutator phenotype; the other excisionless mutants tested (*rad1*, *rad2*, *rad4* and *rad10*) are normal (BRYCHCY and VON BORSTEL 1977).

(2) rad51 (Cox and GAME 1974; MORRISON and HASTINGS 1979) is one of many genes in yeast that are concerned mainly with the repair of ionizing radiation damage and only to a small extent with the repair of UV damage (GAME and Cox 1973; GAME and MORTIMER 1974; Ho 1975; RESNICK 1969b). The process is thought to be error-free for the repair of damage induced by UV and gamma radiation (LAWRENCE and CHRISTENSEN 1976; MCKEE and LAWRENCE 1979a), but mutagenic in the repair of damage induced by ethyl methanesulfonate (PRAKASH 1976). Five of seven X-ray-sensitive mutants belonging to the RAD51 epistasis group are mutators (HASTINGS, QUAH and VON BORSTEL 1976; VON BORSTEL, CAIN and STEINBERG 1971; S.-K. QUAH, unpublished results).

(3) The RAD6 epistasis group consists of more than a dozen mutants (LAW-RENCE 1976, 1979a,b), some of whose functions are implicated in mutagenic repair in induced mutagenesis; the *rad18* mutant is a member of this group (LAWRENCE and CHRISTENSEN 1976). Its mutator phenotype (von BORSTEL, CAIN and STEINBERG 1971; and this report) tends to suggest that its gene product is concerned with error-free repair (LAWRENCE and CHRISTENSEN 1979a,b). UV-induced mutagenesis is more often normal than defective in *rad18* strains (LAWRENCE and CHRISTENSEN 1979a), and these strains showed somewhat elevated revertibility with nitrous acid (PRAKASH 1976). Each of the mutator strains—rad3, rad51 and rad18 — was crossed to a rev3 mutant. Spontaneous mutation rates of double mutants were compared to those of the single mutants and the wild-type control strain. The data are presented in Table 3. Table 4 gives the mean values and standard errors for each genotype. The results show that the rev3 mutation is epistatic to all three radiation-sensitive mutations with respect to the rate of spontaneous mutation. The lys1-1 reversion rates of all three types of double mutants are characteristic of those seen in rev3 single mutants. The *his1-7* reversion rates are intermediate between those of rev3 single mutants and wild-type strains. Spontaneous mutation rates to suppression seem to vary according to genotype. The double mutants involving either rad3 or rad51 show lower mutation rates than those of the rev3 single mutants. The rev3 double mutants, in contrast to rad3 rev3 and rad51 rev3, show mutation rates to suppression more like those of the wild-type strains.

In view of the existence of a class of mutator mutants that are radiation resistant (HASTINGS, QUAH and VON BORSTEL 1976), such as *mut1* (GOTTLIEB and VON BORSTEL 1976; VON BORSTEL *et al.* 1973), it might be argued that there are other ways for a cell to regulate spontaneous mutation rates. In the absence of information as to whether the *mut1* mutation causes lesions or accumulates lesions because of defective repair, it is nevertheless likely that the *REV3* gene is required to process these lesions. We investigated this possibility by constructing *mut1 rev3* double mutants; Table 5 shows that mutator activity is still present in the double mutants. Unlike other mutator strains, the *mut1* mutation often reduced the *lys1-1* locus reversion rates below those of the wild type (GOTTLIEB and VON BORSTEL 1976; VON BORSTEL *et al.* 1973; S.-K. QUAH, unpublished results). Results presented in Table 5 tend to suggest that this antimutator activity of the *mut1* mutation might interact additively with the antimutator effect of the *rev3* mutation.

The observation that mut1 mutator activity is independent of REV3 gene function can be interpreted to mean that another mutagenic process repairs spontaneous lesions in *mut1* strains. To better understand *mut1*-mediated enhanced spontaneous mutagenesis, an antimutator mutation was induced in a mut1 background. This second mutation, ant1, confers UV, but not gamma-ray, sensitivity upon the strain; it segregates independently from the mut1 mutation. However, the mutation does not completely remove the mutator activity of mut1 (Table 6). The double mutants still show mutator activity, but only at about 17% to 38%, depending on the marker, of the rates seen in mut1 single mutants. Strains carrying only the *ant1* mutation were backcrossed to wild type; the results in Table 7 show that UV sensitivity segregated with reduced mutation rates for suppression and for reversion of his1-7. There may or may not be an effect on $l\gamma s1-1$ locus reversion rates. We have found that ant1 complements the following mutants for UV survival: rev1, rev3-1, rev3-15, rad3, rad6, rad9, rad18 and rad51. In Figures 2, 3 and 4 we show the UV-survival interactions of ant1 with rev3-15 and representative mutants of the two known repair pathways, rad6 and rad3. Since it has been shown that rev3 and rad6 have an epistatic interaction (LAWRENCE and CHRISTENSEN 1976), the difference in the interaction

The effect of rev3 in combination with rad3, rad51 and rad18 on spontaneous mutation rate

Mutation rate (X 10⁸) 21.50 32.67 38.90 41.59 32.44 48.1119.47 4.25 6.37 4.34 1.94 4.26 4.35 2.58 3.19 2.67 7.2614.14 11.76 5.16 15.27 14.24 6.58 2.24 | I | 1 No. of mutant comps. 529 729 721 265 420 436 437 437 494 494 h:s1-7No. of comps. Cells/ comp. (X 10⁻⁶) 1.83 2.8 2.17 2.602.492.11 2.34<u>.9</u> 1.77 2.83 1.86 2.37 2.37 2.78 2.74 2.18 2.46 2.85] 2.13 1.94 1.89 2.31 2.63 | | Locus 1.06 02 .39 1.37 .58 0.13 0.09 0.02 1 0.11 0.02 00.0 0.08 0.08 0.02 0.51 0.42 Mutation rate ($\times 10^8$) 0.51 0.22 0.89 0.34 0.39 1 6.405.96 4.49 4.70 5.51 0.87 1.21 0.66 0.76 1.50 1.80 1.49 1.52 2.04SS 1 2.55 1.80 1.982.09 1 2.01 1.59 2.88 No. of mutant compartments Locus \$ 74 64 88 53 L ~ 10 10 9 20 ŝ 01 22543028333 lyst-1 287 257 45 45 52 35 46 46 46 92 92 237 SS 96 81 96 [19]
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<l ļ No. of comps. 998 782 <u> 9</u>95 581 987 984 986 997 996 991 1 980 959 993 988 963 948 977 783 395 984 963 999 1 $\begin{array}{c} \text{Cells} / \\ \text{comp.} \\ (\times \ 10^{-6}) \end{array}$ 2.14 3.39 2.562.683.233.06 2.252.73 3.42 3.61 2.93 2.80 3.44 3.22 3.12 3.23 3.47 3.48 I 1 1 2.94 3.23 3.17 3.20 Y0414-4C Y0414-1D Y0414-4A Y0415-2A Y0415-6A Y0418-5B Y0418-6A Y0415-1A 70415-1C Y0415-2D (0415-6D Y0414-1B Y0415-2C Y0415-6B Y0414-1C Y0414-4B (0414-4D Y0415-2B 70415-6C {0425-1B (0415-1B (0415-1D (0418-8D (0425-1A (0425-1D (0425-1C Y0414-2B VO418-8B Strain Wild type rad3 rev3 Genotype rad3 rev3

TABLE 3

SPONTANEOUS MUTATIONS IN YEAST

				lys1–1							
		C_H_/		No. of	mutant	Mut	ation		his	1-7	
Genetree	Strain	Cells/comp.	No. of comme	compar SS	Tocus	ss (X 1() ^e)	Cells/ comp.	No. of	No. of mutant	Mutation
	meno		- como	8		8	TOOTES	()	comps.	comps.	rate (> 10 ⁻)
Icpar	YU430-3B	I			1	1	I	1.61	1000	561	25.25
	Y0436-4B	1.82	991	427	18	15.50	0.50	1.66	966	538	23.31
	Y0436-11A			1	1	1	I	1.48	966	671	37.53
	Y0436-2D	1.73	1000	408	40	15.16	1.18	1.44	1000	795	55.07
	Y0436-5B	1.99	666	463	41	15.62	1.05	1.76	966	812	47.66
rad51 rev3	Y0436–3C	0.93	266	12	ŝ	0.65	0.16	1.53	1000	77	2.61
	Y0436-4A	1.18	266	15	01	0.64	0.09	1.45	498	35	2.40
	Y0436-11B	1.17	866	6	3	0.39	0.13	1.43	266	45	1.62
	Y0436-7D	0.82	1000	7	1	0.43	0.12	0.87	993	71	4.25
rev3	Y0436–3A	2.67	989	80	61	1.58	0.04	2.77	266	64	1.16
Wild type	Y0436-3D			[l	[2.62	9 68	308	7.03
rad18	Y0294-4A	2.12	1000	419	12	12.79	0.28	1.67	1000	610	28.15
	Y0424-4D	2.26	1000	434	16	12.60	0.36	1.97	966	499	17.61
	Y0424-3A	2.62	998	603	31	17.67	0.60	1.81	866	602	25.48
	Y0417-2B	1.89	866	398	7	13.48	0.19	1.83	966	265	24.93
	Y0424-5D	2.71	966	575	27	15.88	0.51	2.08	866	633	24.00
rad18 rev3	Y0424-4B	2.16	1000	141	4	3.51	0.09	1.67	966	211	7.03
	Y0424–3B	2.11	866	144	e,	3.70	0.07	1.71	988	133	4.23
	Y0417-2A	1.73	266	11	4	2.32	0.12	1.48	897	132	5.39
	Y0424-5B	ł		1			l	1.80	998	139	4.14
	Y0424-6B	2.10	1000	156	1	4.04	0.02	1.89	934	95	2.82
	Y0424-6D	2.63	803	11	0	1.92	NR	2.10	993	155	4.03
rev3	Y0424-4C	3.62	1000	67	7	1.41	0.10	2.73	1000	133	2.48
	Y0424-3C	3.20	995	104	7	1.72	0.11	2.24	962	86	2.09
	Y0417-2D	3.61	925	42	0	0.64	0.03	2.51	666	92	1.91
	Y0424–5A	3.49	266	112	4	1.71	0.06	2.65	666	129	2.56
Wild type	Y0424-4A	3.25	1000	176	37	2.98	0.58	2.25	986	308	8.14
	Y0424-3D	2.51	266	152	29	3.30	0.59	2.49	891	216	5.56
	Y0417-2C	1.78	266	71	22	2.08	0.63	1.64	996	187	6.49
	Y0424-5C	3.20	1000	161	23	2.74	0.36	2.51	666	288	6.71

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TABLE 3-Continued

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* NR = No revertant.

TABLE 4

				Mutati	ion rate (X 10 ⁸)		_	
			lys	1-1					
		SS			Locus			his1–7	
Genotype	N	x	SE	N	x	SE	N	x	SE
rad3	5	5.6	0.4	5	1.30	0.1	7	34	4.0
rad51	3	15.4	0.1	3	0.90	0.2	5	38	6.0
rad18	5	14.0	1.0	5	0.39	0.07	5	24	2.0
rad3 rev3	5	0.8	0.1	5	0.09	0.02	5	4.2	0.7
rad51 rev3	4	0.53	0.07	4	0.12	0.02	4	2.7	0.6
rad18 rev3	5	3.1	0.4	5	0.06	0.02	6	4.6	0.6
rev3	10	1.5	0.1	10	0.06	0.01	10	2.5	0.3
Wild type	12	2.3	0.2	12	0.50	0.05	12	10	1.0

A summary of the mean mutation rates of single and double mutants with standard errors using data from Table 3

N = number of strains; $\bar{x} =$ mean; SE = standard error.

of *ant1* with *rev3* and with *rad6* is inconsistent because *ant1* interacts epistatically with *rev3* but not with *rad6*.

Finally, to find out how much of the wild-type spontaneous mutation is *REV3* and *ANT1* dependent, we measured mutation rates of strains doubly mutant at these two loci. Results presented in Table 8 show that the mutation rates of *ant1* rev3 double mutants, depending on the markers tested, are like those of either rev3 or *ant1* single mutants.

DISCUSSION

One interesting finding that has emerged from a genetic analysis of the origin of spontaneous mutation in yeast has been the uncovering of an antimutator mutation that is an allele of rev3. The REV3 gene function has been shown to be involved in the mutagenic repair of UV-induced damage (LAWRENCE and CHRIS-TENSEN 1976, 1979b; LEMONTT 1971a,b). This mutagenic repair process in yeast appears to involve a large number of genes (LAWRENCE and CHRISTENSEN 1976, 1979a,b). The observation that spontaneous mutation rates are reduced in strains carrying *rev3* mutations suggests that this process is also responsible for a large proportion of spontaneous mutations seen in wild-type strains. The results of double-mutant studies showing that rev3 mutation is epistatic to mutator mutations of rad3, rad51 and rad18 support the hypothesis (HASTINGS, OUAH and von Borstel 1976) that enhanced spontaneous mutation rates seen in radiationsensitive mutator strains are a result of mutagenic repair of spontaneous lesions, and that spontaneous lesions are recognized and repaired by the same enzymatic processes as those that repair induced lesions. The fact that a deficiency in nonmutagenic repair leads to higher spontaneous mutation rates can be taken as evidence that most spontaneous lesions are repaired nonmutagenically in a wildtype strain. Our results show that spontaneous mutations still occur, though at

		lyst-1					hi	s1-7	
Cells/	No. of	No. of compar	mutant tments	Mutat rate (X	ion 10 ⁸)	Cells/	No of	No. of	Mutation
$(\times 10^{-6})$	comps.	SS	Locus	SS	Locus	$(\times 10^{-6})$	comps,	comps.	$rate(\times 10^8)$
0.83	966	764	63	88.25	0.12	2.29	929	740	34.64
0.68	896	612	33	84.30	0.25	2.21	948	069	29.15
0.86	966	838	0	107.48	NR*	2.39	986	772	31.79
1.08	866	927	0	122.03	NR	2.22	995	771	33.45
3.77	998	58	3	0.80	0.04	2.46	991	136	2.40
3.45	1000	71	7	1.07	0.10	2.52	971	142	3.14
2.92	1000	157	18	2.93	0.31	2.37	949	279	7.34
3.41	266	204	26	3.35	0.39	2.24	9 95	446	13.11

* NR = No revertant.

The mutator activity of mut1 is independent of the REV3 gene product

TABLE 5

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TABLE 6The effect of ant1 on mut1

		Cells/	J. IN	No. of compar	mutant tments	Mutat rate (X	ion 10 ⁸)	Cells/	1	No. of	M. 4. 42
Genotype	Strain	$(\times 10^{-6})$	comps.	SS	Locus	SS	Locus	$(\times 10^{-6})$	comps.	comps.	rate($\times 10^8$)
mut1	XV800-6C	1.63	666	875	6	64.04	0.28	6.27	966	571	36.27
<i>mut1</i> (UV-)	289	1.70	1000	293	61	10.18	0.06	0.94	266	304	19.09
mut1	Y043-9D	2.11	1000	988	ŝ	105.03	0.12	1.56	987	732	41.98
	Y043-12A	2.06	994	894	15	55.67	0.37	1.12	1000	729	58.18
	Y0133-1C	1.47	932	860	ŝ	87.19	0.11	1.18	883	474	32.49
mut1 ant1	Y043-9A	2.30	992	502	16	15.33	0.35	1.49	266	517	24.08
	Y043-12D	2.06	266	463	ç	15.16	0.12	1.26	1000	343	16.37
	Y0133-1A	2.89	953	436	œ	10.59	0.15	2.69	974	549	15.43
ant1	YO43-9B	2.29	066	14	17	0.31	0.38	1.36	866	118	4.64
	Y043-12B	2.64	991	27	11	0.52	0.21	1.55	266	167	5.93
	Y0133-1D	4.06	840	27	25	0.40	0.37	2.03	935	218	6.53
Wild type	Y043-9C	1.89	966	48	17	1.30	0.45	1.12	666	244	11.78
	Y043-12C	2.38	395	74	16	1.62	0.34	1.40	1000	367	16.25
	Y0133-1B	4.29	887	170	20	2.48	0.27	1.46	066	212	8.25

SPONTANEOUS MUTATIONS IN YEAST

	spontaneous mutation rate
	low
	with
BLE 7	sensitivity
ΤA	UV
	of
	segregation
	howing
	nalysis s
	Tetrad a

				lys1–1					17		
		Cells/	9 - TV	No. of compa	mutant rtments	Mut rate (ation × 10 ⁸)	Cells/		No. of	
Tetrad	UV	$(\times 10^{-6})$	comps.	SS	Locus	SS	Locus	$(\times 10^{-6})$	roomps.	comps.	rate $(\times 10^8)$
Y075-2A	S	2.02	1000	23	11	0.58	0.27	2.43	983	156	3.55
-2B	S	2.05	866	21	10	0.52	0.25	2.76	066	256	5.43
-2C	Я	1.76	666	4	20	1.28	0.57	2.35	266	440	12.41
-2D	R	1.88	866	99	16	1.82	0.43	2.18	974	299	8.40
Y075-3A	В	4.05	266	125	23	1.65	0.29	2.29	226	528	16.98
-3 B	R	4.07	966	202	43	2.78	0.54	2.96	926	415	10.02
-3C	S	5.11	266	51	21	0.51	0.21	3.04	973	171	3.16
-3D	S	4.55	966	40	25	0.45	0.28	2.44	953	295	7.24
Y075-4A	S	3.23	<u>995</u>	42	17	0.67	0.27	3.23	771	195	4.51
-4B	s	3.08	3 95	16	14	0.26	0.23	2.60	066	308	7.10
-4C	R	2.29	666	116	20	2.70	0.44	2.48	066	472	13.04
-4D	R	2.04	666	57	27	1.44	0.67	2.02	1000	602	22.75

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FIGURE 2.—UV survival curves for wild-type (YO119-3B), ant1 (YO119-3D), rev3-15 (YO119-3C) and ant1 rev3-15 (YO119-3A) haploid strains. Three other ant1 rev3-15 doublemutant strains gave survival curves similar to the rev3-15 single-mutant strain.

a reduced rate, in rev3 strains. It is not known whether these mutations are due to leakiness of the rev3 mutation, to unrepaired misreplication errors or to a minor mutagenic pathway, as yet unidentified, operating in these strains.

It appears, as shown in Tables 2 and 3, that the rad3 rev3 and rad51 rev3 double mutants specifically reduce suppressor mutation rates to levels lower than those of the rev3 single mutants. A possible explanation is that the repair processes controlled by the RAD3 and RAD51 gene loci are slightly mutagenic. It is conceivable that excision repair of a spontaneous lesion could result in an intermediate substrate that is potentially more mutagenic. On the other hand, it is difficult to measure the spontaneous mutation rate accurately enough at such



FIGURE 3.—UV survival curves for wild-type (YO106-2C), ant1 (YO106-2B), rad6-1 (YO106-2D) and rad6 ant1 (YO106-2A) haploid strains. Two other experiments using different sets of tetratype tetrads gave similar results.

low rates to exclude totally any modifier effects. However, if the lower mutation rate is due to segregation of a modifier gene, the results shown in Table 2 give no evidence for tight linkage. Unlike rad3 rev3 and rad51 rev3 double mutants, rad18 rev3 double mutants show suppressor mutation rates similar to those of the wild-type strains. This implies that a proportion of the spontaneous mutation seen in rad18 single mutant strains is not caused by the *REV3* gene product.

When we examined the influence of the rev3 mutation on a mut1 mutator strain that is insensitive to the lethal effect of radiation or MMS, we found that the *REV3* gene function is not required for the enhanced mutation seen in mut1 mutant strains. This implies that other spontaneous lesions or configurations exist that are repaired by processes independent of those defined by the *RAD3*, *RAD51*, *RAD18* and *REV3* loci. The isolation of an antimutator strain, ant1, which is also a repair-deficient mutant, is compatible with the conclusion that another mutagenic process besides that controlled by the *REV3* gene exists. The incomplete action of the ant1 mutation in the reduction of mutator activity in the mut1 strain could be attributed to leakiness of the ant1 mutation or to other causes that have yet to be uncovered.

The fact that the rev3 mutation is epistatic to ant1 with respect to UV survival can be taken to mean that ant1 belongs to the RAD6 epistatic group; however, ant1 is not defective in UV-induced mutagenesis as determined by our test systems (data not shown). Furthermore, we have found that ant1 rad6 double mutants are more sensitive to the lethal effects of UV radiation than is either single mutant, a result inconsistent with the finding that rad6 is epistatic to rev3



FIGURE 4.—UV survival curves for wild-type (Y0169-1A), ant1 (Y0169-1B), ant1 rad3 (Y0169-1C) and rad3 (Y0169-1D) haploid strains. Two other experiments using different sets of tetratype tetrads gave similar results.

(LAWRENCE and CHRISTENSEN 1976). Although rev3 is epistatic to ant1 with regard to UV survival, they show distinct mutation phenotypes; the rev3 mutant exhibits a strong effect on lys1-1 and his1-7 reversions; whereas, ant1 is more effective on suppressor mutations. The rev3 ant1 double mutant shows a spontaneous mutation phenotype characteristic of ant1 for suppressor mutations and of rev3 for lys1-1 and his1-7 reversions. Together, their functions appear to account for about 90% of the spontaneous mutation of these test alleles in the wild type. The independent behavior of these two mutations with respect to the spontaneous mutation rate is consistent with the idea that their gene functions are employed to produce different mutational events. Such a conclusion has been reached by LAWRENCE and CHRISTENSEN (1976, 1978a,b, 1979b) on UV-induced mutagenesis. Examples of variation in mutation phenotypes were provided in their studies of UV-induced reversion of $c\gamma c1$ alleles in strains defective in induced mutagenesis. They showed that the RAD6 function appears to be necessary for the production of all kinds of mutations at all sites; in contrast, the REV3 gene function is required to revert most, but not all, mutational events. MCKEE and LAWRENCE (1979a,b) proposed that the RAD6 system was composed of several sets of overlapping functions, in which partially different sets of genes are required by different types of mutations, mutations at different positions in the genome, and the formation of mutations by different mutagens. The findings with ant1 and rev3 support this view, extending it to spontaneous mutation.

				lys1-1						r	
		Cells/	No of	No. of compa	mutant rtments	Mut rate (:	ation × 10 ⁸)	Cells/		No. of	
Genotype	Strain	$(\times 10^{-6})$	comps.	SS	Locus	SS	Locus	$(\times 10^{-6})$	INO. OI comps.	mutant comps.	rate $(\times 10^6)$
ant1 rev3	Y0119-2A]		I				2.79	835	43	0.95
	Y0119-2C	[l	ļ	I		1	2.53	953	2	2.05
	Y0119-3A	3.64	986	19	4	0.27	0.06	2.72	918	41	0.84
	Y0119-4A	4.00	954	47	10	0.63	0.13	2.81	949	63	1.22
ant1	Y0119-3D	4.90	296	50	18	0.54	0.19	3.03	606	326	7.34
	Y0119-4B	3.95	975	44	26	0.58	0.34	2.63	881	205	5.03
rev3	Y0119-3C	3.80	982	73	8	1.02	0.11	2.30	988	103	2.39
	Y0119-4C	3.22	991	66	0	1.64	NR*	2.46	962	110	2.47
Wild type	Y0119-2B	j	I	l		1		2.72	994	552	14.49
	Y0119-2D	1]	I	1	1	2.10	981	395	12.27
	Y0119-3B	2.71	968	180	35	3.79	0.68	1.79	973	169	5.32
	Y0119-4D	3.53	993	83	42	1.24	0.61	2.23	951	456	14.67

* NR == No revertant.

TABLE 8 Mutation rate of ant1 rev3-15 double mutant

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Since rev3 mutants are antimutators, one would expect from the mutational phenotype based on UV-induced mutagenesis that rad6 mutants would also be antimutators. This apparently is not so, for rad6 mutations have been shown to enhance, rather than reduce. the spontaneous mutation rate (HASTINGS. OUAH and von Borstel 1976; LAWRENCE and CHRISTENSEN 1979a). This inconsistency might lie in the complexity of the RAD6-dependent functions that have been discussed by LAWRENCE and CHRISTENSEN (1979a). They proposed that the RAD6-dependent functions can be described as a highly branched process dependent on the cooperative action of more than a dozen loci. In addition to the mutagenic repair functions, there are at least two different error-free functions: (1) a RAD18-dependent process that is responsible for UV and trimethoprim resistance, and (2) a RAD9- and RAD15-dependent process that is responsible for the error-free repair of gamma-ray damage. Metabolic suppressor mutations were found to suppress only the former process. Since rad6 and rad18 mutants are both mutators, it can be interpreted that the RAD18-dependent process also repairs spontaneous lesions and, when this error-free process is not available. these lesions are repaired mutagenically by the REV3 gene product. This idea is consistent with the fact that rad18 rev3 double mutants are not mutators. The lack of an antimutator effect seen in *rad6* single mutants may occur because of a compensatory increase in mutagenic repair by the REV3 gene function. If this were true, the influence of a *rad6* mutation on spontaneous mutation rates would be more obvious in a rev3 background. The phenotypes of rad6 rev3 double mutants are vet to be determined.

We do not know the origin or nature of the spontaneous lesions that lead to spontaneous mutation in yeast. At present, we visualize the functions that are lost in these antimutator mutants as functions connected with the ability of repair polymerases to cross lesions in a variety of situations. An important question for further work is the origin of the low level of spontaneous mutation still present in *ant1 rev3* double-mutant strains.

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